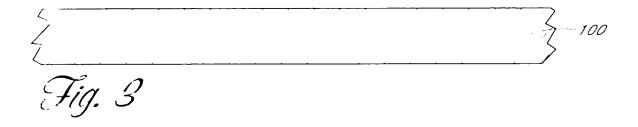
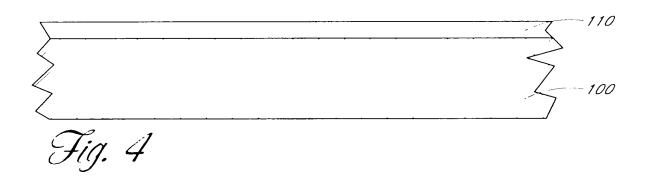
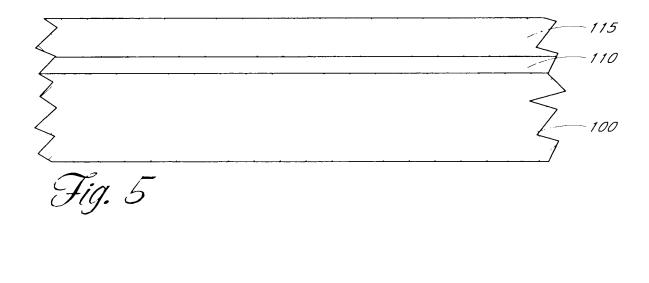
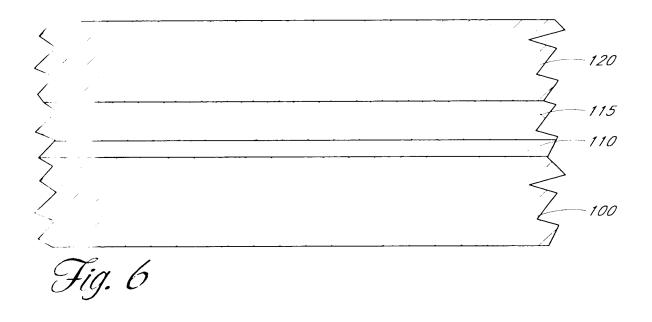


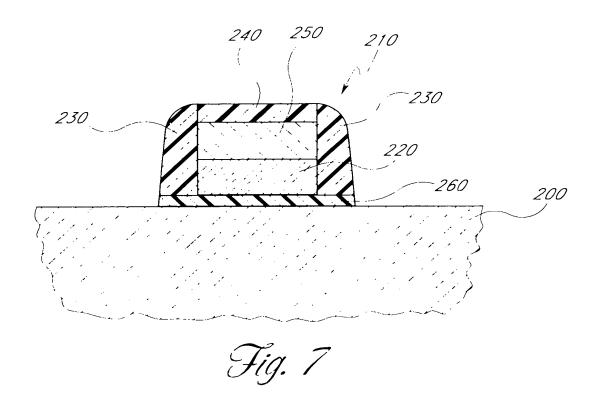
Fig. 2











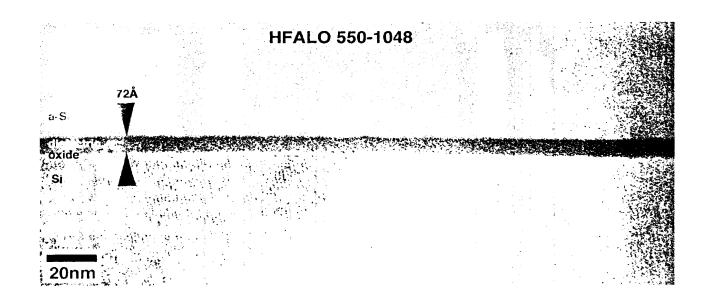
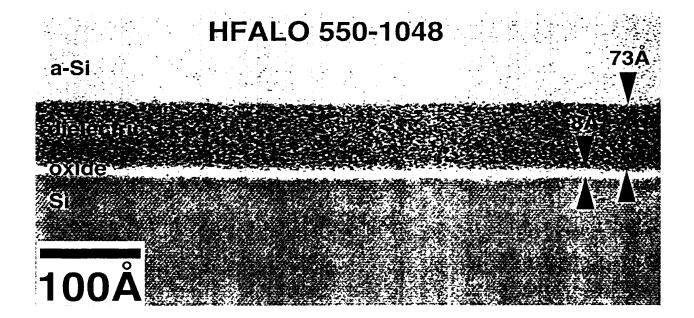


Fig. 8



Jig. 9

1548

ерэху

a-Si



Fig. 10

1548 high-k 100Å

Jig. 11

1548

a-Si

oxide

100Å

Fig. 12

1548 a-Si layer

wafer surface

100Å

1548 surface of a-Si

ероху

a-Si

100Å

Fig. 14